



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi IGARASHI et al.

Group Art Unit: 3727

Application No.: 10/611,918

Examiner: H. SHAKERI

Filed: July 3, 2003

Docket No.: 108833.01

For: LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS  
MEASUREMENT METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the October 20, 2008 Notice of Panel Decision from Pre-Appeal Brief  
Review, the period for reply being extended by the attached Petition for Extension of Time,  
and in consideration of the attached Request for Continued Examination, please consider the  
following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**